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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tsuga et al. Art Unit: 1746  
Serial No.: 10/085,725 Examiner: Kornakov, M.  
Filing Date: 02/28/2002 Docket No.: TI-31621  
Customer No.: 23494 Conf. No.: 1672  
Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON  
SEMICONDUCTOR WAFERS

OFFICIAL

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by  
facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on  
the date shown below.

Jacqueline J. Garner, Reg. No. 36,144

June 21, 2004  
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner  
for an extension of the shortened statutory period for response in the above-identified  
Application.

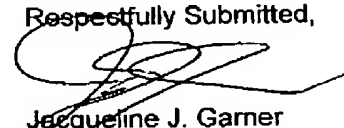
The fee for this extension is indicated below:

- ☐ One Month (\$110)  
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☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary  
extension of time is hereby requested. Charge any and all fees to deposit account no. 20-  
0668. An original and two copies of this sheet are enclosed.

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Respectfully Submitted,

  
Jacqueline J. Garner  
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